

***In situ* Accelerator-Based Characterization
of CaO/Sr/Pd Samples
under Deuterium Permeation**

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▪ **Deuterium permeation through Pd/(CaO+Pd)/Pd sample induced nuclear transmutations;**

$^{133}\text{Cs} \rightarrow ^{141}\text{Pr}$, $^{88}\text{Sr} \rightarrow ^{96}\text{Mo}$, $^{138}\text{Ba} \rightarrow ^{150}\text{Sm}$ and $^{137}\text{Ba} \rightarrow ^{149}\text{Sm}$.

1. Y. Iwamura, M. Sakano and T. Itoh; Jpn. J. Appl. Phys. 41 (2002) 4642-4650.

2. Y. Iwamura, T. Itoh, M. Sakano, S. Kuribayashi, Y. Terada, T. Ishikawa and J. Kasagi; Proc. ICCF11, 2004, Marseilles, France.

In the present work;

● **The objective is**

- to investigate the dependence of the transformation rate on **material, D flux, flow direction, temperature, etc.**
- to find the optimum sample **structure.**
- from a point of view of enhancing the transformation **yield.**

● **Diagnostic methods;**

***in situ* and simultaneous measurements of compositional change during D permeation by accelerator analyses;**

PIXE (Particle induced X-ray emission analysis)

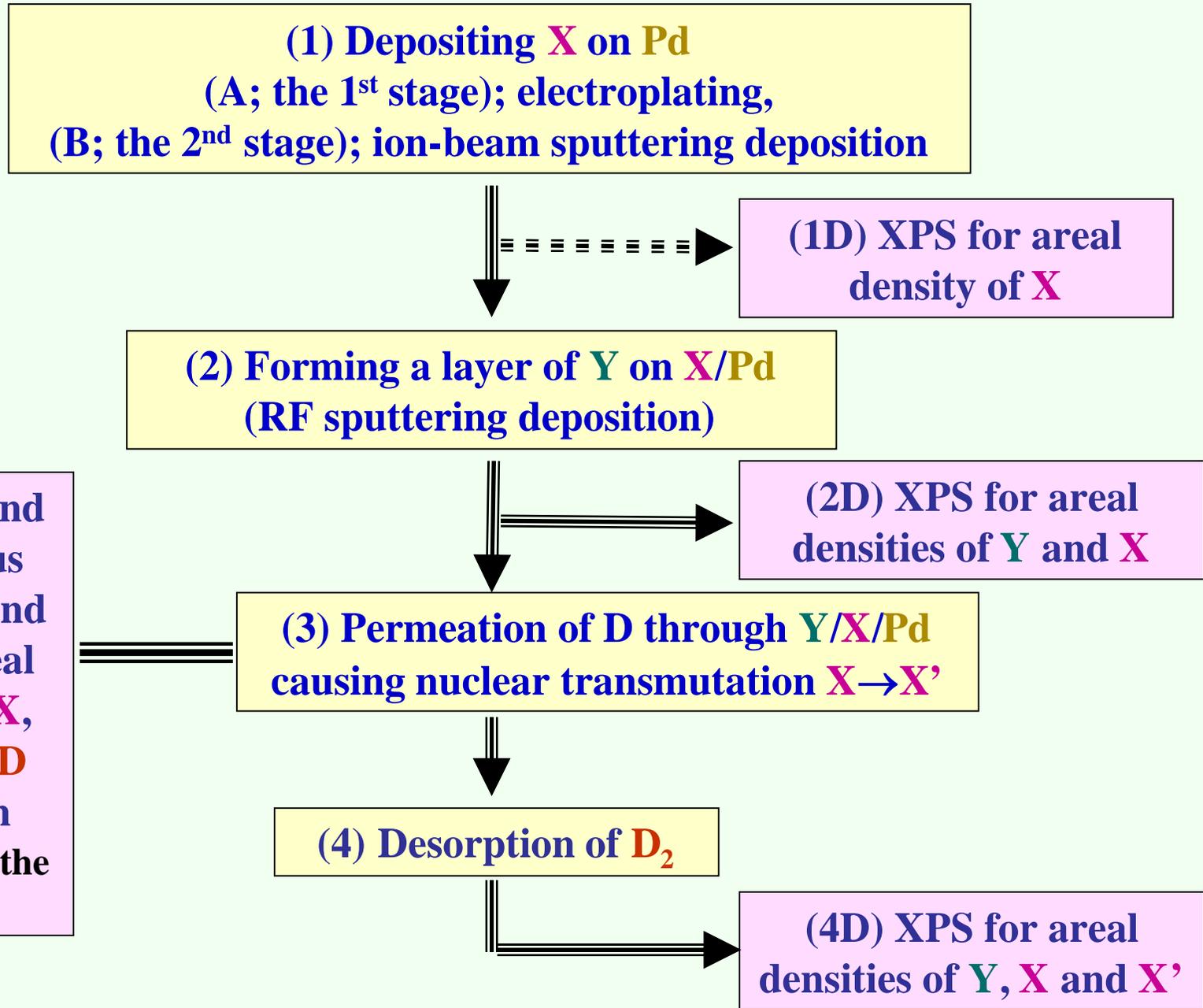
RBS (Rutherford backscattering spectroscopy)

NRA (Nuclear reaction analysis)

ERDA (Elastic recoil detection analysis)

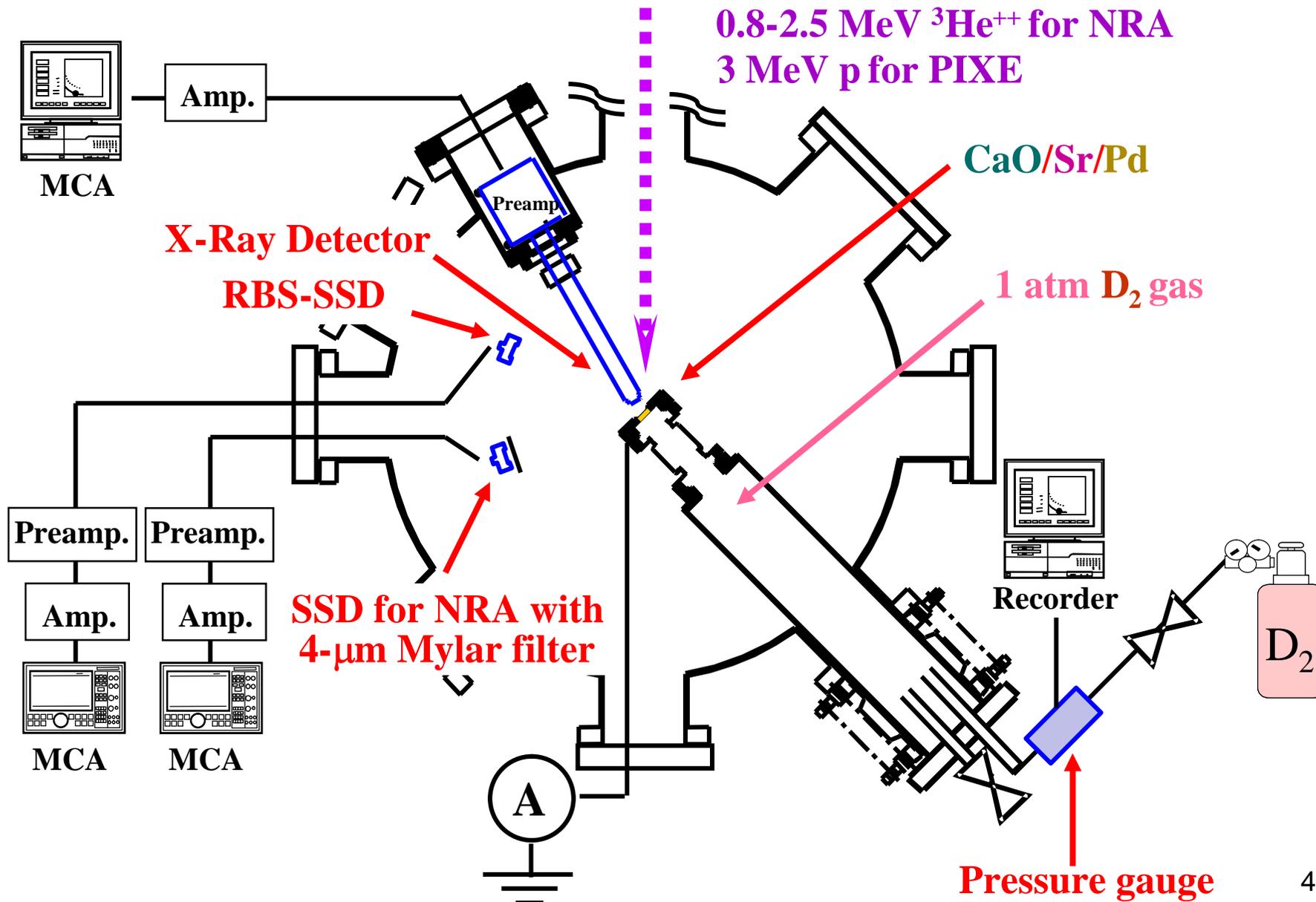
as well as conventional XPS and Desorption measurements.

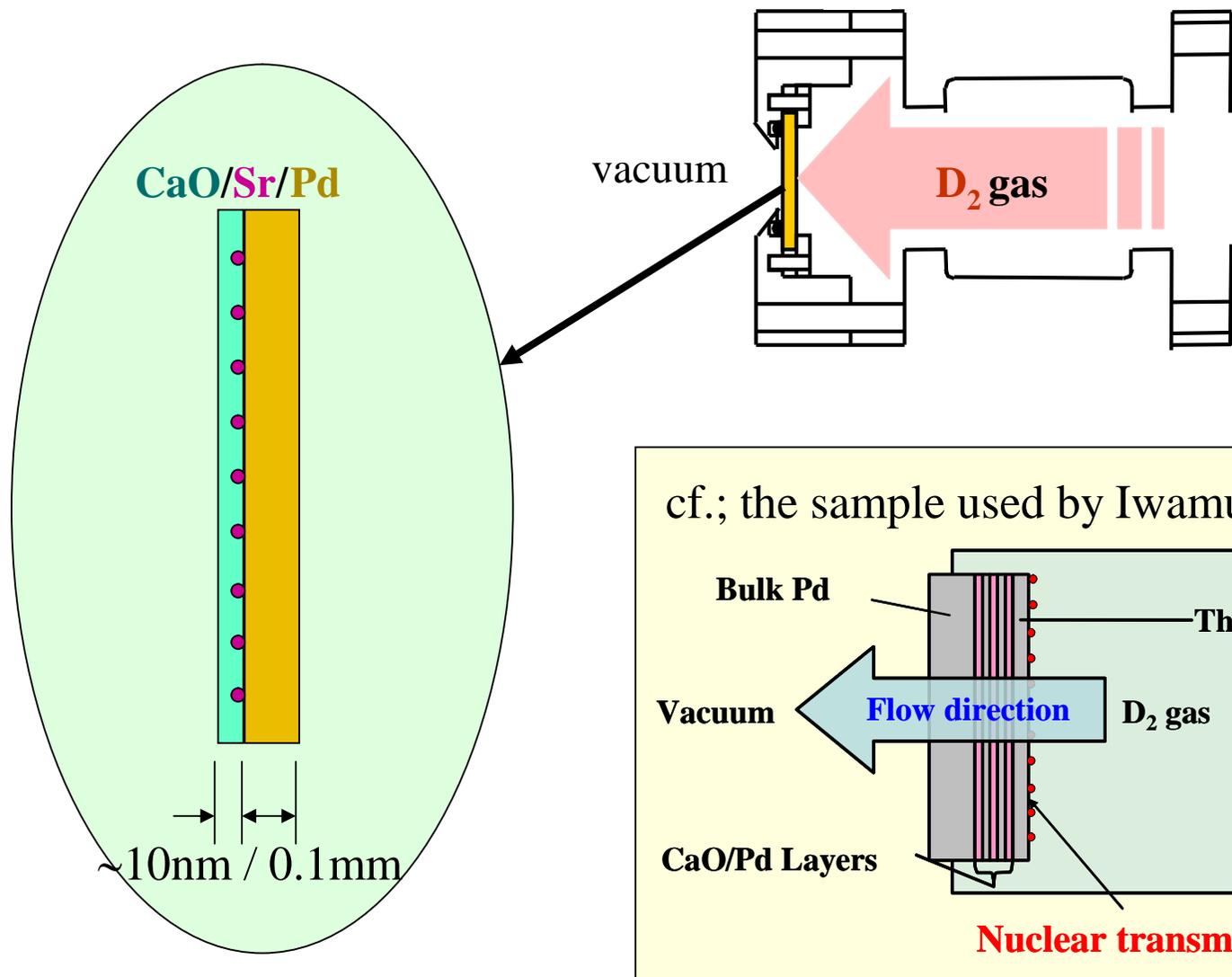
Experimental procedure; in the present work, **X = Sr**, **Y = CaO**



Probe beam ions from PELLETRON 5SDH2

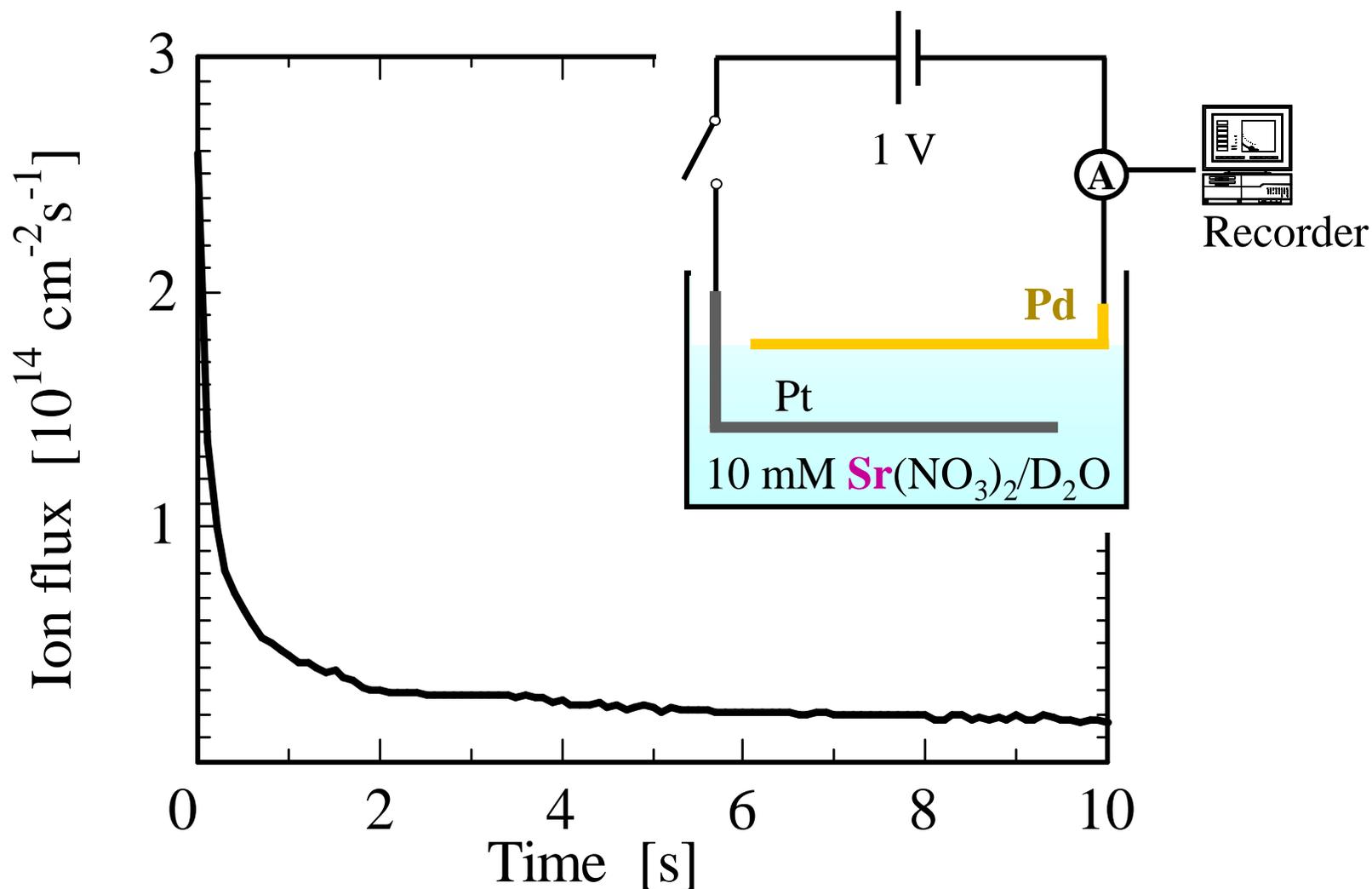
0.8-2.5 MeV $^3\text{He}^{++}$ for NRA
3 MeV p for PIXE





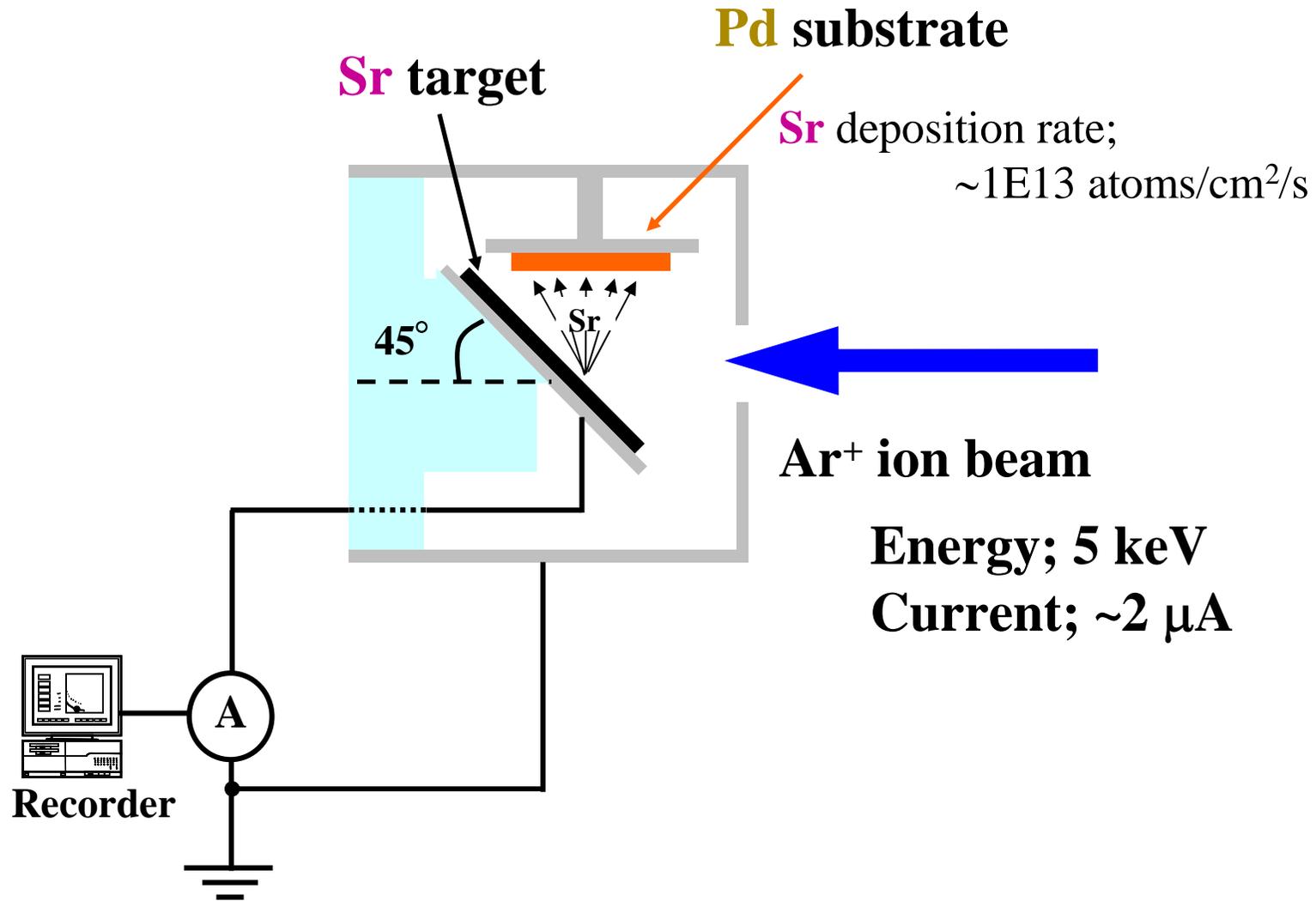
Deuterium permeates through the CaO(~10nm)/Sr/Pd sample from the rear surface out to vacuum.

(1) Depositing Sr on Pd ; (A) electrochemical method



Sr atoms are deposited on one side of a 0.1-mm-thick Pd foil as contamination with an areal density of the order of 10^{14} cm^{-2} .

(1) Depositing Sr on Pd ; (B) ion beam sputtering

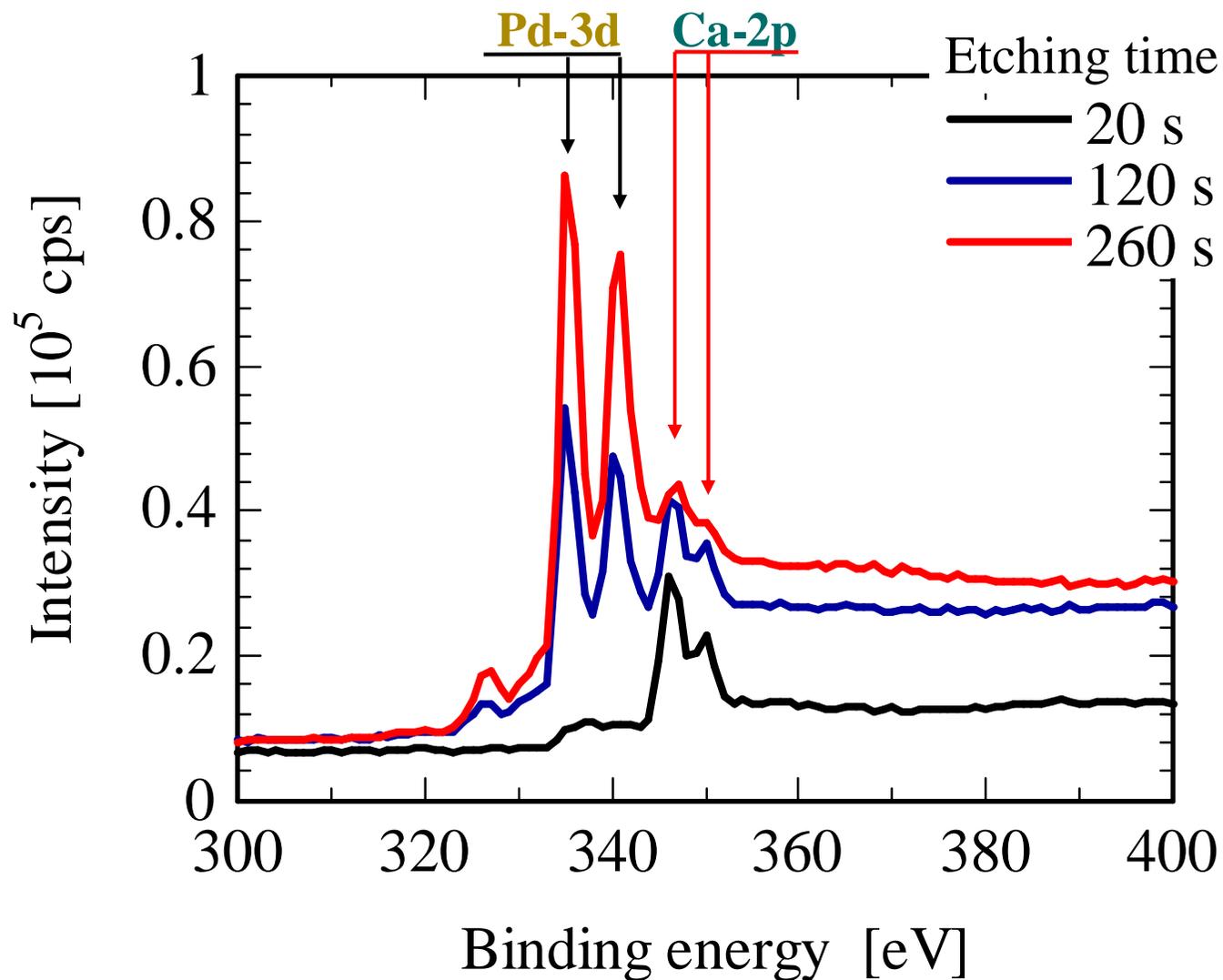


(2) Forming a layer of CaO on Sr/Pd ; RF sputtering deposition

RF sputtering condition

- Cathode (sputter target); CaO
- Anode (sample); Sr/Pd
- Ar pressure; 0.1 Torr
- RF power; 100 W
- Plasma exposure time; 5 - 30 min.
- Sample temperature; 450 K
- CaO deposition rate; 0.1 - 0.5 nm/min

(2D) XPS characterization after forming the layer of CaO on Sr/Pd



Change in the sample structure is reflected in XPS spectra after repetitive etching of the CaO/Sr/Pd surface.

- The CaO layer thickness x is calculated from the intensity ratio of these peaks, $Y_{\text{Ca-2p}}/Y_{\text{Pd-3d}}$;

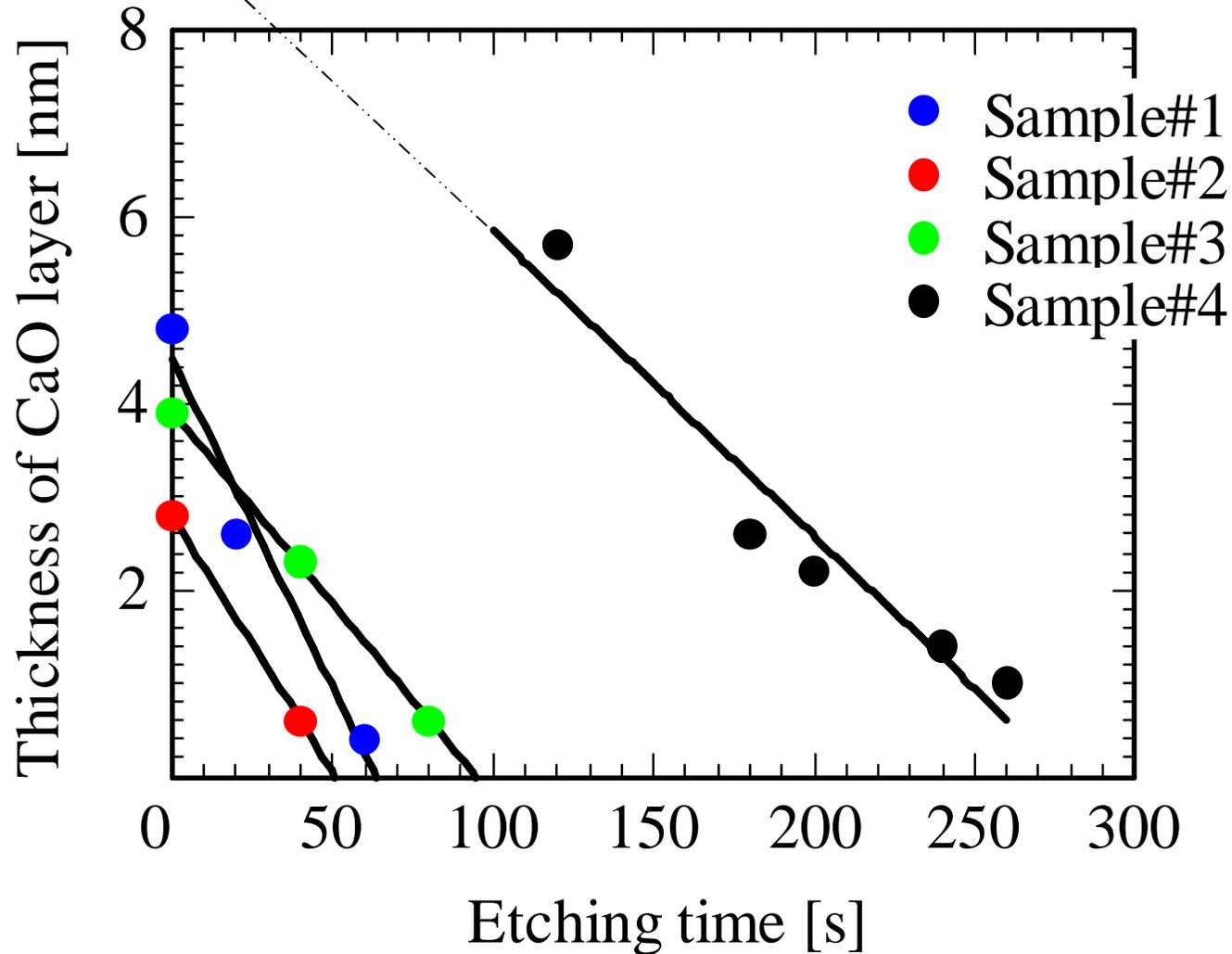
$$\exp\left(\frac{x}{\lambda_{\text{CaO-Pd}}}\right) \cdot \left(1 - \exp\left(-\frac{x}{\lambda_{\text{CaO-Ca}}}\right)\right) = \frac{n_{\text{Pd}} \cdot \sigma_{\text{Pd}} \cdot \lambda_{\text{Pd-Pd}} \cdot Y_{\text{Ca-2p}^{3/2}}}{n_{\text{Ca}} \cdot \sigma_{\text{Ca}} \cdot \lambda_{\text{CaO-Ca}} \cdot Y_{\text{Pd-3d}^{5/2}}}.$$

where

$$Y_{\text{Ca-2p}^{3/2}} = \phi_p \cdot S \cdot n_{\text{Ca}} \frac{d\sigma_{\text{Ca}}}{d\Omega} \Delta\Omega \cdot \int_0^x \exp\left(-\frac{t}{\lambda_{\text{CaO-Ca}}}\right) dt,$$

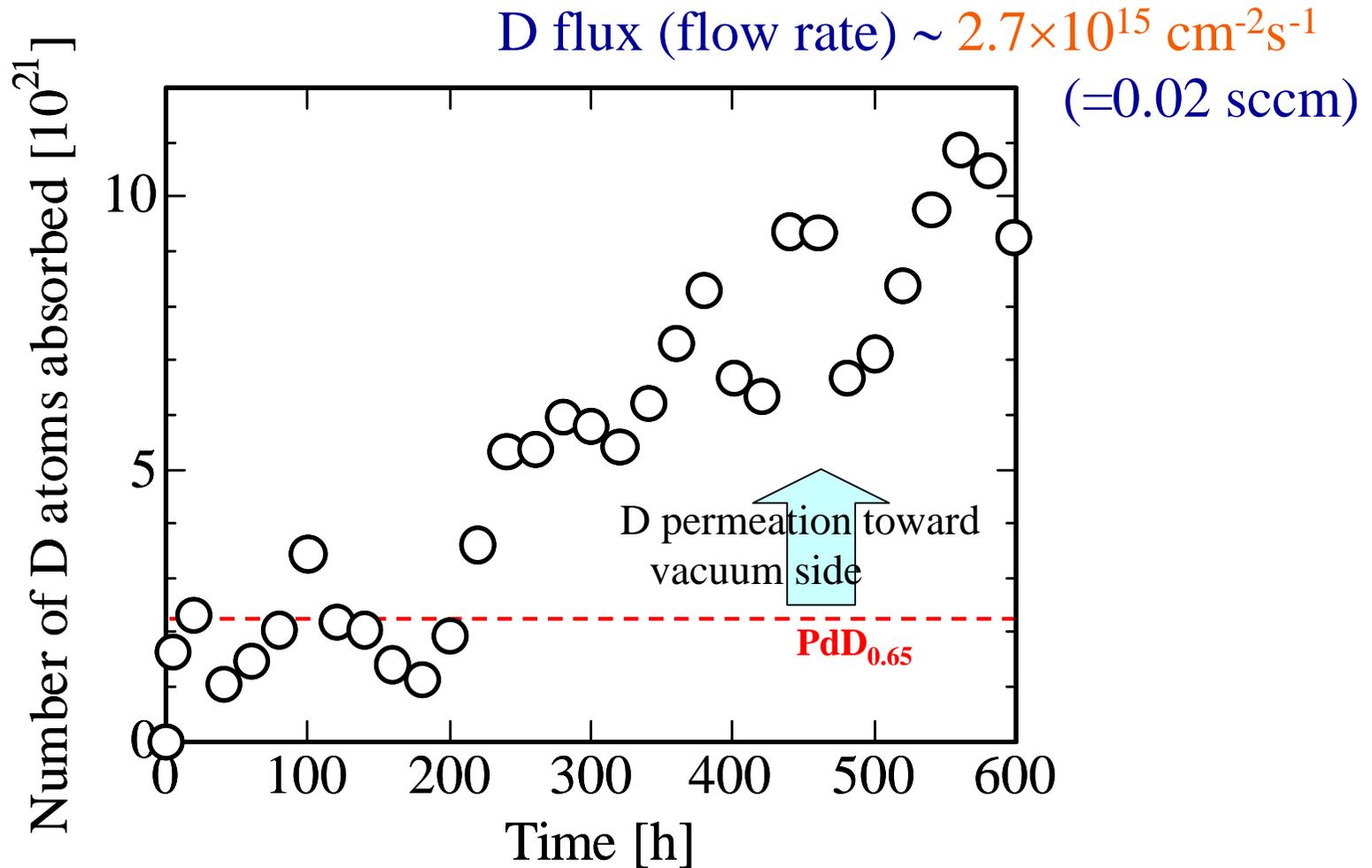
$$Y_{\text{Pd-3d}^{5/2}} = \phi_p \cdot S \cdot n_{\text{Pd}} \frac{d\sigma_{\text{Pd}}}{d\Omega} \Delta\Omega \cdot \exp\left(-\frac{x}{\lambda_{\text{CaO-Pd}}}\right) \int_0^\infty \exp\left(-\frac{t}{\lambda_{\text{Pd-Pd}}}\right) dt.$$

(2D) XPS characterization after forming the layer of CaO on Sr/Pd



The thickness of the CaO layer has been calculated from the XPS yield of the Pd-3d peak relative to that of Ca-2p to be about 10 nm for the sample #4.

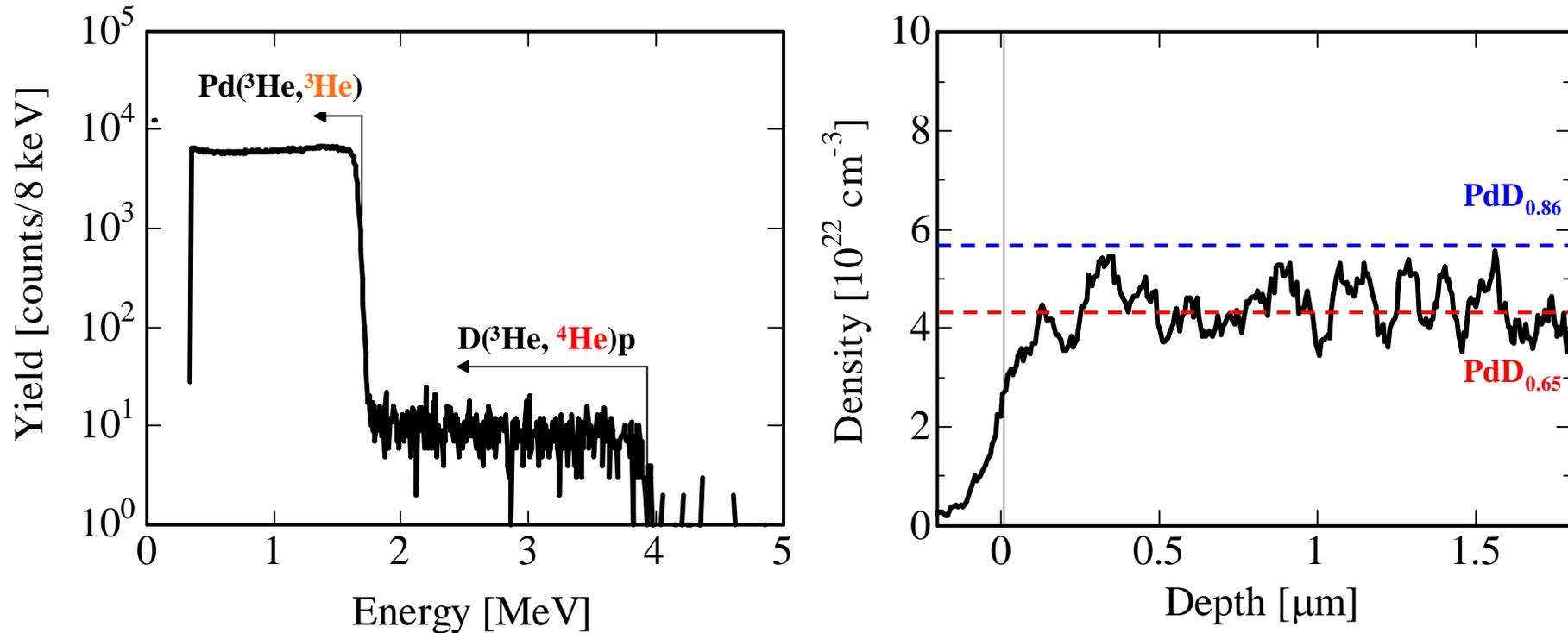
(3) Permeation of D through CaO/Sr/Pd (the sample B)



During D permeation, pressure in the reservoir has been monitored to calculate the number of absorbed/transmitted D atoms.

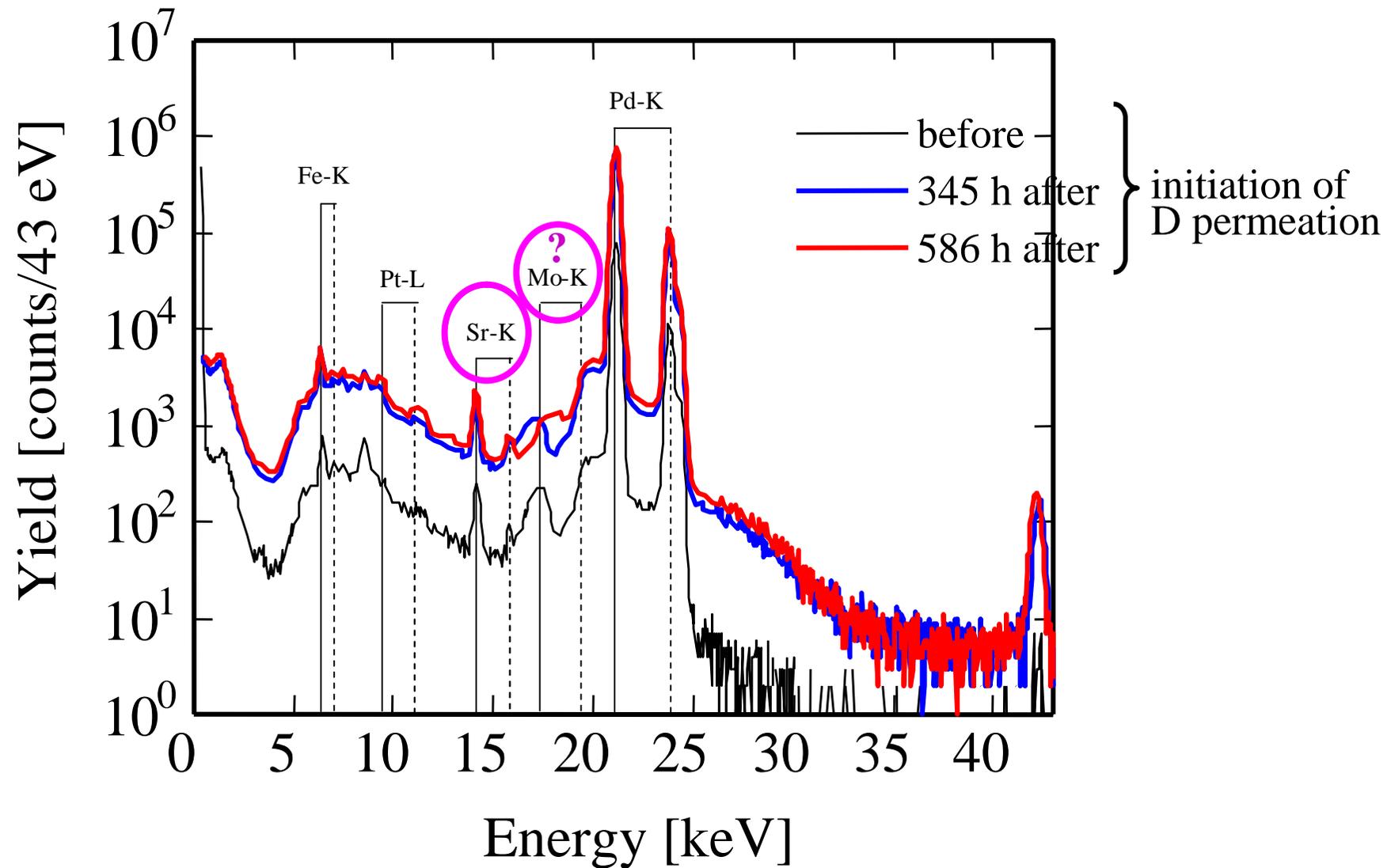
(3D) NRA during permeation of D through CaO/Sr/Pd (the sample B)

NRA using the $D(^3\text{He}, ^4\text{He})p$ reaction



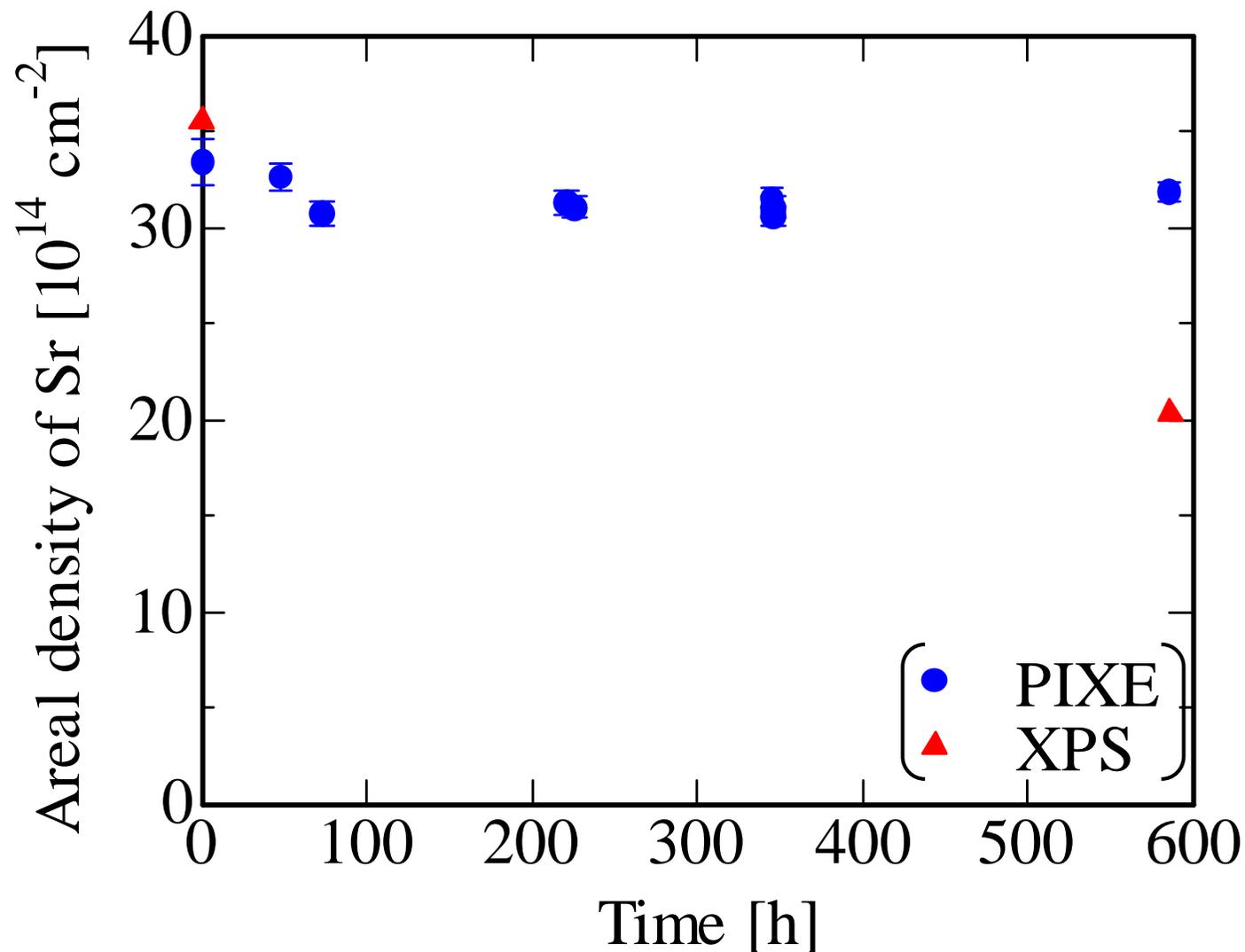
The NRA revealed the almost uniform composition of $\text{PdD}_{0.65}$ over the depth region of 0-1.8 μm .

(3D) PIXE analysis during permeation of D through CaO/Sr/Pd (the sample B)



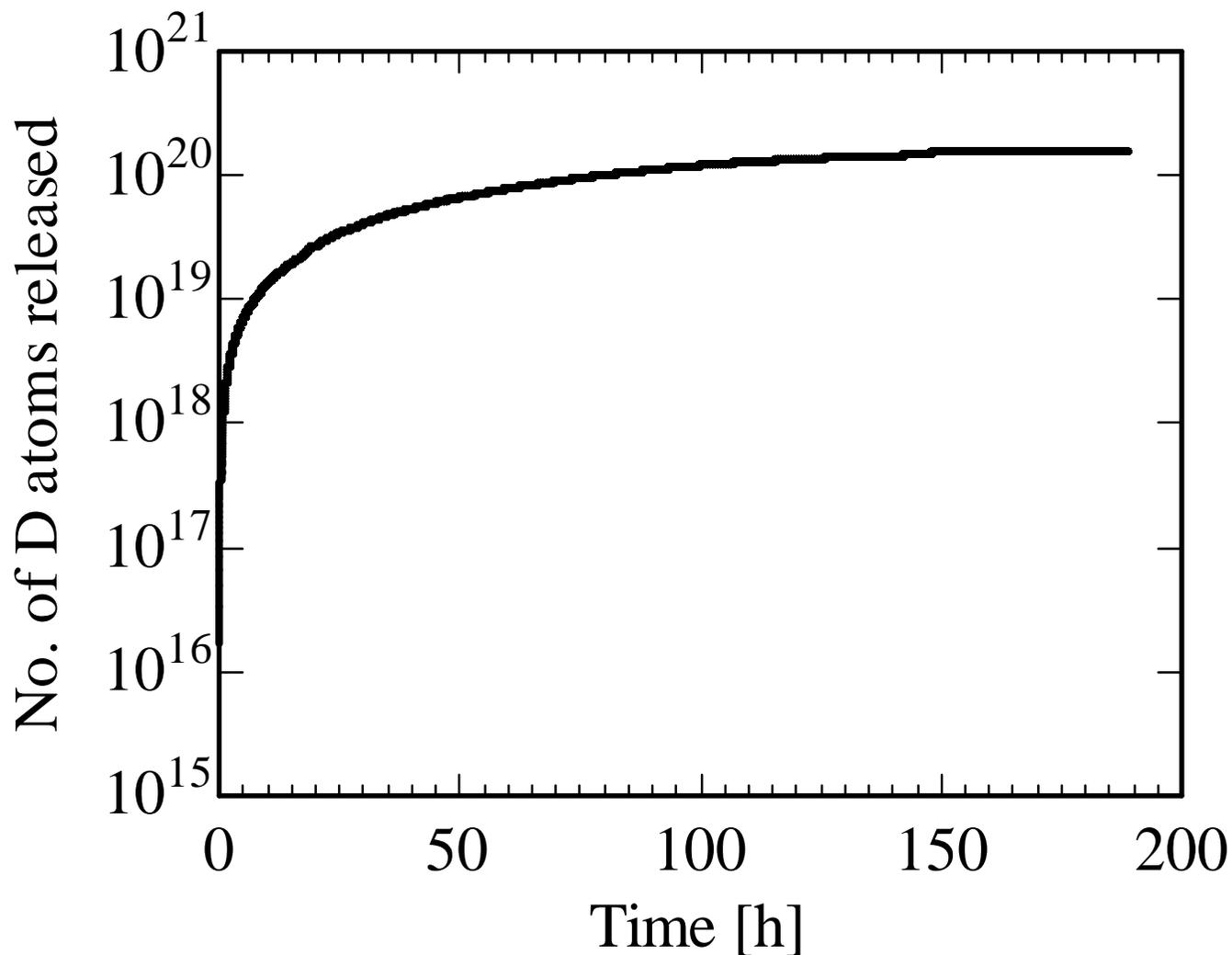
The PIXE spectra revealed existence of a variety of impurities. The Mo- $K_{\alpha/\beta}$ seems to be interfered by unidentified broad peaks.

(3D) PIXE analysis during permeation of D through CaO/Sr/Pd (the sample B)



Variation of the areal density of Sr during permeation of D for 590 hours. Results of ex-situ XPS are also plotted for comparison.

(4) Desorption of D₂



Outgassing of the sample after finishing D permeation was necessary for introduction into the XPS chamber. Total amount of desorbed D atoms measured with QMS indicates D/Pd~0.3.

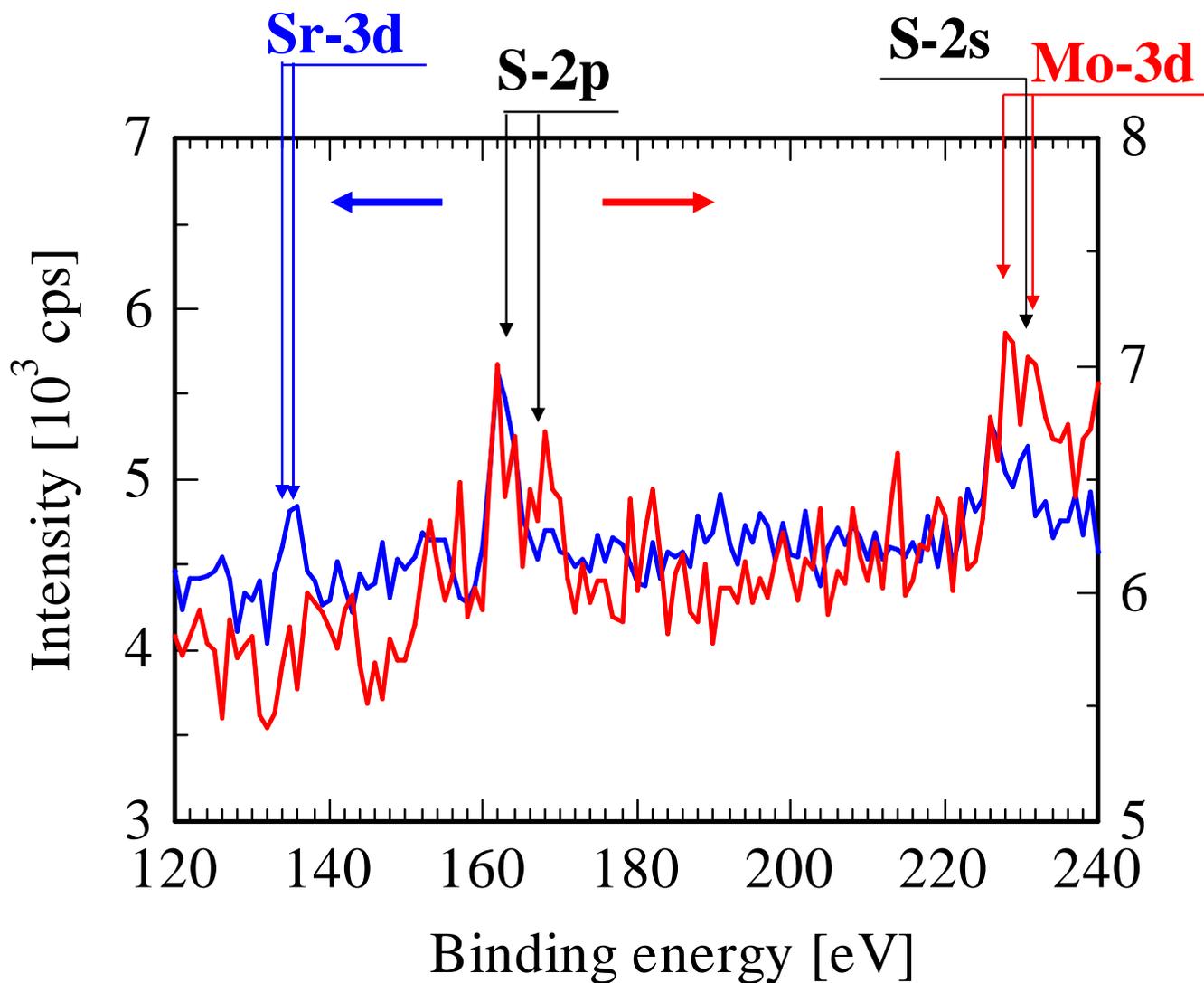
- The process of deuterium charging is described by a 1-dimensional solution of the diffusion equation for the sample with a thickness and area of a and S , respectively.
- One side of the sample is assumed to be opaque for deuterium, while the other facing to hydrogen gas to give a boundary condition for the deuterium density; $n(a) = n_0$.
- The number of deuterium atoms absorbed in the sample, $N_a(t)$, is given as a function of time by

$$N_a(t) = aSn_0 \left[1 - \sum_{s=0}^{\infty} \left\{ \frac{8}{(2s+1)^2 \pi^2} \cdot \exp \left(- \left(\frac{(2s+1)\pi}{2a} \right)^2 Dt \right) \right\} \right]$$

- A characteristic time $t_{1/2}$ for the number of deuterium atoms absorbed to reach a half of the saturation value, *i.e.*, $N_a(t_{1/2})/aS = N_a(\infty)/2aS = 2.9 \times 10^{22} \text{ cm}^{-3}$, is therefore given by

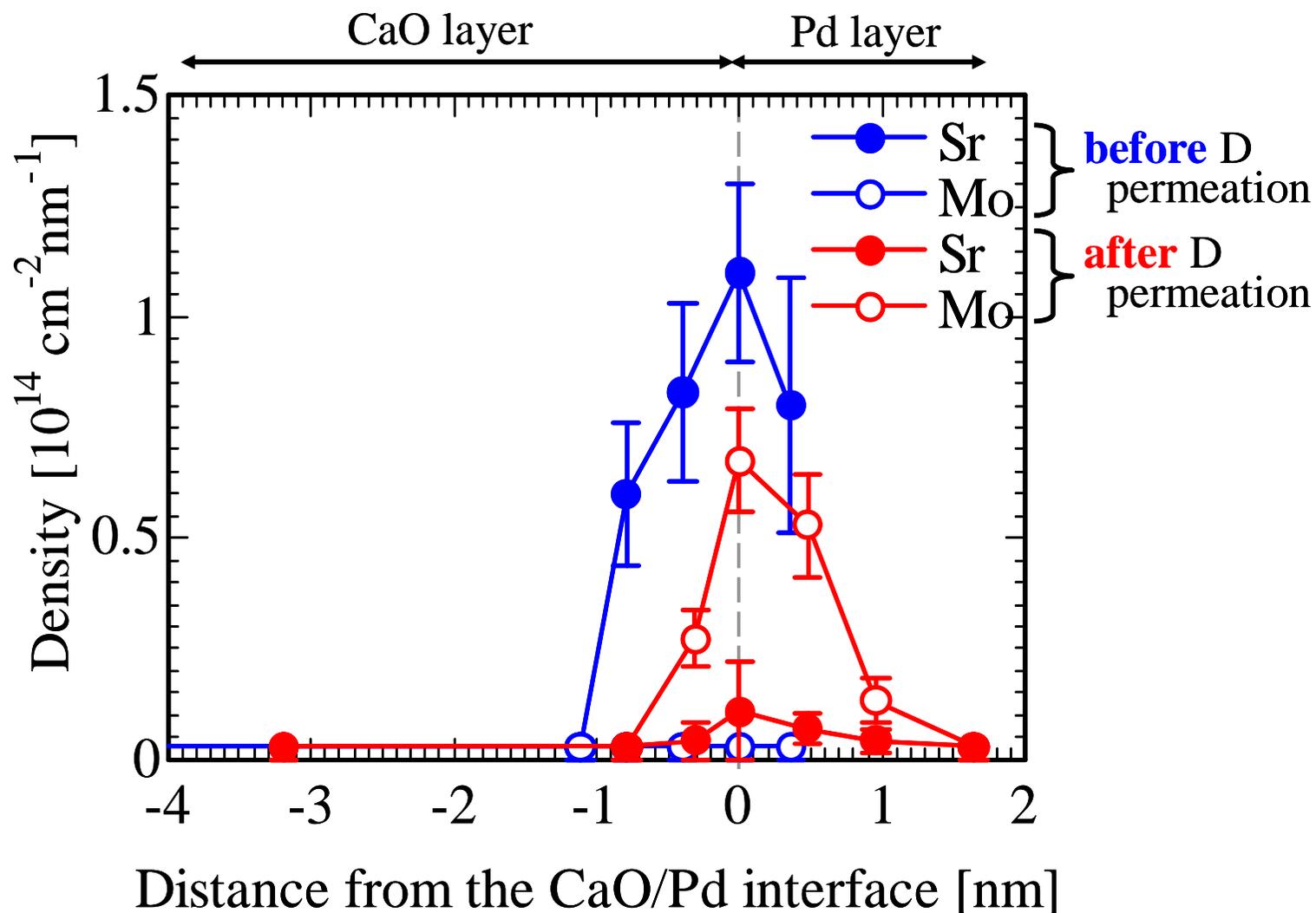
$$t_{1/2} = \frac{0.1967a^2}{D} = 6 \times 10^1 \text{ s}$$

(4D) XPS characterization of the sample **A after D₂ Desorption**



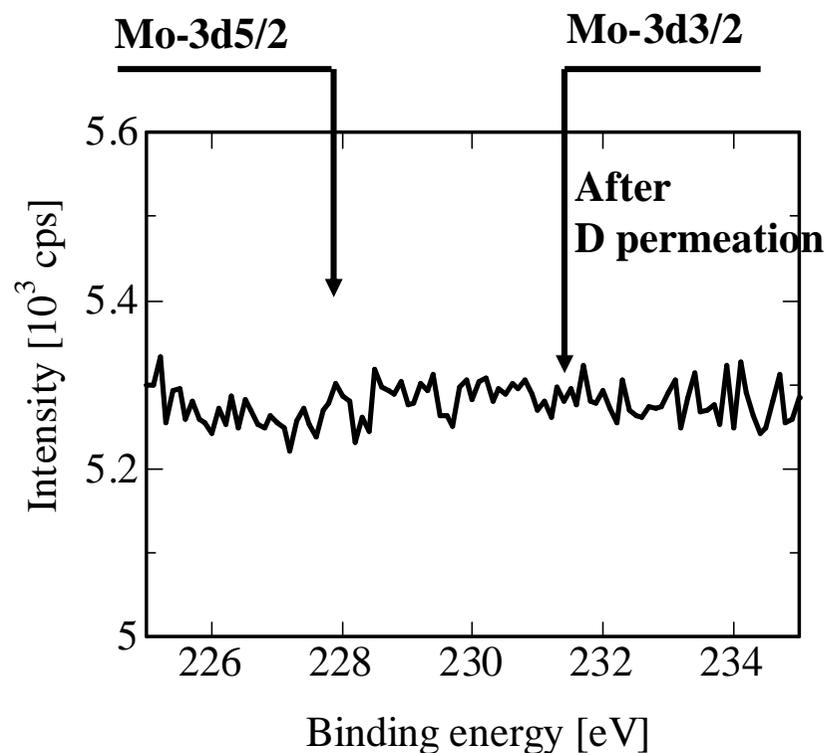
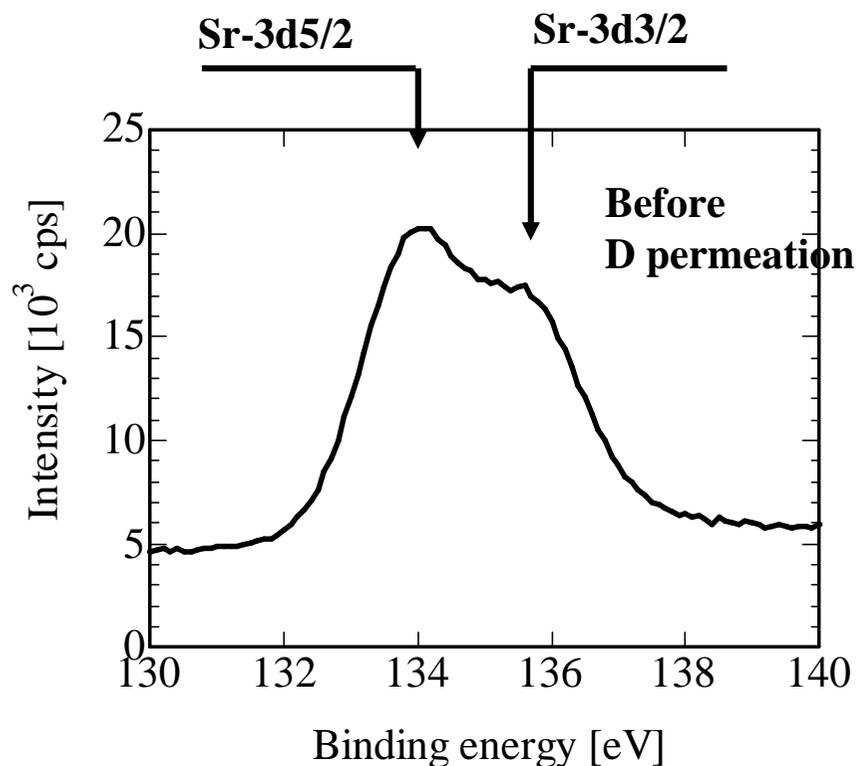
XPS spectra before and after D permeation. Increase in Mo-3d peaks in exchange for decrease in Sr-3d peaks is observed.

(4D) XPS characterization of the sample **A** after D_2 Desorption



XPS analysis implies nuclear transmutation near the CaO/Pd boundary: Sr atoms with areal density of $1.3 \times 10^{14} \text{ cm}^{-2}$ appear to be transformed to Mo atoms of $6.6 \times 10^{13} \text{ cm}^{-2}$ by D permeation.

(4D) XPS characterization of the sample B after D₂ Desorption



An order of magnitude increase in areal density of Sr (~2 monolayers) was realized by RF sputtering method. However, nuclear transmutation was not recognized for this sample.

Summary of changes in areal densities

	PIXE			XPS	
	Sr	Mo	Others	Sr	Mo
A (electroplating)	-----	-----	-----	-1.3	+0.66
B (I. B. sputtering)	-2.5	<<+1.9	<<+1	-15	<<+0.11
	areal densities in $1\text{E}14 \text{ cm}^{-2}$				

Sample A: Transmutation efficiency was ~50%.

Sample B: Decrease in areal density of Sr was not followed by consistent increase in other elements observable.

Summary

- (1) Implication of nuclear transmutation $\text{Sr} \rightarrow \text{Mo}$ has been obtained in a system [vacuum/CaO/Sr/PdD_x/D₂], which is a little simpler than that used by Iwamura *et al.*
- (2) The diagnostic method used to identify the elements was conventional XPS, giving the areal densities of $1.3 \times 10^{14} \text{ cm}^{-2}$ (Sr) and $6.6 \times 10^{13} \text{ cm}^{-2}$ (Mo).
- (3) Extended analytical methods have been prepared; *in situ* and simultaneous PIXE, RBS and NRA/ERDA for areal densities of transmutation elements and deuterium distribution.
- (4) Increase in the areal density of Sr to $3.3 \times 10^{15} \text{ cm}^{-2}$ by using ion beam sputtering method resulted in negligible transmutation yield.

Summary

(5) Further experimental work is necessary to confirm the phenomena;

-Dependence on the **density of the atoms to be transmuted, the **areal density** of the atoms, the **flux** (flow rate) of D, the sample structure,**

-Effect of surface **contamination.**